

Micromachine/MEMS



Ministry of Economic Affairs and Energy of the State of North Rhine-Westphalia







29 July 2010 Japanese-German Micro/Nano Business Forum Tokyo Big Sight, East Hall

The Forum, organized by IVAM Microtechnology Network with support of the Micromachine Center will take place during the Exhibition Micromachine/MEMS 2010 on July 29, 2010. The forum intents to deepen the international exchange about applications of micro and nano technologies and create business opportunities between the Japanese and the German Market and worldwide.

Registration Starts 10:10 Moderation: Dr. Uwe Kleinkes, IVAM Microtechnology Network

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		Keiichi Aoyagi
10:25-10:30	Opening	Micromachine Center (Japan) Dr. Uwe Kleinkes
		IVAM Microtechnology Network (Germany)
		Birgit Ogami
		Federal Ministry of Economics and Technology of Germany
10:30-10:40	Opening Remarks	Dr. Peter Scholz
		Ministry of Economics Affairs and Energy of the
		State of North Rhein-Westphalia
10:40-11:10	MEMS project in Tohoku University	Prof. Dr. Masayoshi Esashi
		Tohoku University (Japan)
11.10-11.40	Examples of smart system solutions: from monitoring systems to micro analysis	Prof. Dr. Thomas Geßner
11.10 11.10	systems	Fraunhofer ENAS (Germany)
11:40-12:00	Low emission MEMS and its application for	Assoc. Prof. Dr. Jun Mizuno
	micro device	Waseda University (Japan)
Lunch Moderation: Haruka Kawamoto, IVAM Microtechnology Network		
13:00-13:20	MEMS Technologies Dresden: development and fabrication opportunities	Michael Müller Fraunhofer IPMS (Germany)
	labrication opportunities	•
13:20-13:40	G Device Project	Dr. Ryutaro Maeda National Institute of Advanced Industrial
70.20 70.70		Science and Technology (Japan)
13:40-14:00	Energy efficient and wireless applications in	Dr. Uwe Kleinkes
	European markets with MEMS	IVAM Microtechnology Network (Germany)
14:00-14:20	Patent Stratgies for Micro- and Nanotechnology:	Dr. Robert Harrison
	Exploiting ideas worldwide	24IP Law Group Sonnenberg Fortmann (Germany)
	Break	W
14:40-15:00	MEMS Activities at Panasonic Electric Works	Koji Tsuji Panasonic Electric Works Co., Ltd. Osaka (Japan)
	Cost Advantages of Direct Diode Micro-Materials	Dr. Tanja Bizjak
15:00-15:20	Processing	LIMO Lissotschenko Mikrooptik GmbH (Germany)
15:20-15:40	Smort concer eveteme with MEMS	Dirk Enderlein
	Smart sensor systems with MEMS	MEAS Deutschland GmbH (Germany)
15:40-16:00	Q&A	
16:00-16:20	Closing	Dr. Uwe Kleinkes
10.00 10.20	Olosing	IVAM Microtechnology Network